



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/647,297                      Group Art Unit: 1771  
Filing Date: August 26, 2003                      Examiner: Hai Vo  
Applicants: Hyun HUH et al.  
Title: Polishing Pad Containing Embedded Liquid Microelements  
and Method of Manufacturing the Same  
Attorney Docket: 47881-000003/US

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
**Mail Stop Amendment**

November 5, 2007

**RESPONSE**

Sir:

In response to the Office Action mailed August 3, 2007, the following remarks are respectfully submitted in connection with the above-identified application.

**Listing of the Claims** begins on page 2 of this Amendment.

**Remarks** begin on page 7 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	15	-	31	=	0
<b>Independent</b>	1	-	3	=	0